

1763

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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of  
Akira IZUMI  
Serial No.: 10/634,432  
Filed: August 5, 2003

New York, New York  
Date: November 11, 2003  
Group Art Unit: 1763  
Examiner: Not Yet Assigned

For: **SUBSTRATE PROCESSING APPARATUS AND SUBSTRATE PROCESSING  
METHOD DRYING SUBSTRATE BY SPRAYING GAS**

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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**SUBMISSION**

Sir:

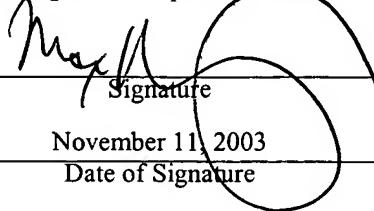
Submitted herewith is a copy of art together with a form listing the same for the convenience of the Examiner.

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Commissioner for Patents P.O. Box 1450,  
Alexandria, VA 22313-1450, on November 11, 2003

Max Moskowitz

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Name of applicant, assignee or  
Registered Representative



Max  
Signature

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November 11, 2003

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Date of Signature

Respectfully submitted,



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